ATTY. DOCKET NO. 050169/0105

In re Patent Application of

Batch No.: K83

Wallace T.Y. TANG

Allowed: October 26, 1998

08/401,229 Serial No.

Group Art Unit: 2874

March 9, 1995 Filed:

Examiner: J. Lee

Publishing Division

MAR 23 1999

For:

IN-SITU REAL-TIME MONITORING TECHNIQUE AND

APPARATUS FOR ENDPOINT DETECTION OF THIN FILMS

DURING CHEMICAL/MECHANICAL POLISHING

PLANARIZATION

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.56

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

In accordance with the duty of disclosure under 37 C.F.R. §§ 1.56 and 1.98, Applicant wishes to bring to the attention of the U.S. Patent and Trademark Office the references listed on the enclosed Form PTO-1449. Copies of the listed references are enclosed.

Respectfully submitted,

March 17, 1999

Date

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Should additional fees be necessary in connection with the filing of this paper, or if a petition for extension of time is required for timely acceptance of same, the Commissioner is hereby authorized to charge Deposit Account No. 19-0741 for any such fees; and applicant(s) hereby petition for any needed extension of time.

Sheet 1 of 1				Attorney Docket No. 050169/0105					
FORM TO 1449 (modified)				ATTY DOCKET NO. 0%9169/0105 SERIAL NO. 08/401,229					
U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE				APPLICANT: Wallace T.Y. TANG					
LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)				FILING DATE: March 9, 1995 GROUP: 2874					,
Date Submitted to P1	TO: Mar	ch 17, 1999		U.S. PATENT DOCUMENTS					
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS		SUBCLASS	FILING DATE IF APPROPRIATE	
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FOREIGN PATENT DOCUMENTS									
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS		SUBCLASS	TRANSLATION YES NO	
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)									
	A: Novembre BACUS - 9th Annual Symposium, "Automated Process-Gentrol of Poly(Butene-1-Sulfone) at al. PBS Resist Development," (September 1989) pp. 139-144								
		A. Novembre	SPIE_Vol.=1087-Integrated Circuit Metrology, Inspection, and Process Control-III-(1989)						
		et.al. An'in Situ interrerometric Analysis of Resist Development on Photomask-Substrates, pp. 460-468							
		A. Novembre SPIE, Vol. 1809, 12th Annual BACUS Symposium (1992), "Initial manufacturing performance-of an actively							
		et al controlled PBS resist development process (pp. 76-84							
EXAMINER DATE CONSIDERED									

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.